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## BIB DATA SHEET

CONFIRMATION NO. 7705

<b>SERIAL NUMBER</b> 10/585,079	<b>FILING or 371(c) DATE</b> 07/23/2007 <b>RULE</b>	<b>CLASS</b> 372	<b>GROUP ART UNIT</b> 3742	<b>ATTORNEY DOCKET NO.</b> 292853US2PCT	
<b>APPLICANTS</b> Hans Peter Chall, Beuningen, NETHERLANDS; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/NL04/00922 12/29/2004 <b>** FOREIGN APPLICATIONS *****</b> EUROPEAN PATENT OFFICE (EPO) 03079210.5 12/30/2003 <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 02/07/2008					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /GEOFFREY 3742 S EVANS/ Acknowledged Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> NETHERLANDS	<b>SHEETS DRAWINGS</b> 3	<b>TOTAL CLAIMS</b> 13	<b>INDEPENDENT CLAIMS</b> 2
<b>ADDRESS</b> OBLON, SPIVAK, MCCLELLAND MAIER & NEUSTADT, L.L.P. 1940 DUKE STREET ALEXANDRIA, VA 22314 UNITED STATES					
<b>TITLE</b> Method, Device and Diffraction Grating for Separating Semiconductor Elements Formed on a Substrate by Altering Said Diffraction Grating					
<b>FILING FEE RECEIVED</b> 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		